

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14564-006002	Application No. 10/778,019
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Garbuzov et al.	
		Filing Date February 13, 2004	Group Art Unit 2828

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
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Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AL						
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	Ito, R. and Nakamura, M., Foundation and Application of Semiconductor Laser, BAIFUKAN CO., LTD., 1st Edition, 5th printing, pp. 50-53 and 82-84, March 30, 1995 (Japan), English translation (Japanese language version was previously submitted).
	AR	
	AS	
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